

## Freeform Search

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<b>Database:</b>	US Pre-Grant Publication Full-Text Database US Patents Full-Text Database US OCR Full-Text Database EPO Abstracts Database JPO Abstracts Database Derwent World Patents Index IBM Technical Disclosure Bulletins
<b>Term:</b>	<input type="text" value="L1 and nitride"/>
<b>Display:</b>	<input type="text" value="10"/> Documents in <b>Display Format:</b> <input type="text"/> Starting with Number <input type="text" value="1"/>
<b>Generate:</b>	<input type="radio"/> Hit List <input checked="" type="radio"/> Hit Count <input type="radio"/> Side by Side <input type="radio"/> Image

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### Search History

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**DATE:** Sunday, March 20, 2005 [Printable Copy](#) [Create Case](#)

<u>Set</u>	<u>Name</u>	<u>Query</u>	<u>Hit</u>	<u>Set</u>
			<u>Count</u>	<u>Name</u>
	side by side			result set
		DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=OR		
<u>L2</u>	L1 and nitride		95	<u>L2</u>
<u>L1</u>	capacitor and ((ALD or (atomic adj layer adj deposition)) with (aluminum adj oxide))		120	<u>L1</u>

END OF SEARCH HISTORY